Electronic Pate	nt App	lication Fee	Transm	ittal			
Application Number:	10	10559135					
Filing Date:	11-	11-Feb-2008					
Title of Invention:	Sul	Substrate Polishing Apparatus And Substrate Polishing Method					
First Named Inventor/Applicant Name:	Tet	Tetsuji Togawa					
Filer:	Da	David Ovedovitz/Janae Johnson					
Attorney Docket Number:	200	2005-1890A					
Filed as Large Entity	•						
U.S. National Stage under 35 USC 371 Fil	ing Fee	s					
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:					1		
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
Extension-of-Time:							
Extension - 1 month with \$0 paid		1251	1	130	130		

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)				
Miscellaneous:								
Request for continued examination	1801	1	810	810				
	Tot	940						